

Notice of References Cited

Application/Control No.

10/644,036

Applicant(s)/Patent Under
Reexamination
YANG ET AL.

Examiner

William T. Leader

Art Unit

1795

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-			
	B	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages
	U	Robert W. Berry et al, Thin Film Technology, Van Nostrand Reinhold Company, New York, 1968, pp.3-5.
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* A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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